# PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

### **CONVEYING PARTY DATA**

Name	Execution Date
MATHEW DENNIS ROWE	05/11/2020

## **RECEIVING PARTY DATA**

Name:	HALLIBURTON ENERGY SERVICES, INC.	
Street Address:	3000 N. SAM HOUSTON PARKWAY E.	
City:	HOUSTON	
State/Country:	TEXAS	
Postal Code:	77032-3219	

## **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	17008176

### **CORRESPONDENCE DATA**

Fax Number:

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

**Phone:** 12819624503

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ATTORNEY DOCKET NUMBER:	1560-118700
NAME OF SUBMITTER:	JOHN ROSS FLYNT
SIGNATURE:	/rflynt/
DATE SIGNED:	08/31/2020

**Total Attachments: 2** 

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PATENT 506231649 REEL: 053660 FRAME: 0577

### ASSIGNMENT

Whereas, I, Mathew Dennis Rowe of Spring, Texas, ("ASSIGNOR"), have invented PLASMA OPTIMIZATION WITH FORMATIONAL AND FLUID INFORMATION, and

Whereas, **Halliburton Energy Services, Inc.**, a Delaware Corporation having a place of business at 3000 N. Sam Houston Parkway E., Houston, Texas 77032-3219, United States of America (sometimes hereinafter called "ASSIGNEE"), is desirous of acquiring an interest therein,

NOW, THEREFORE, for good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, I do hereby ASSIGN, SELL and CONVEY to said **Halliburton Energy Services**, **Inc.**, its successors and assigns, the entire right, title and interest throughout the world in and to:

- 1. Said invention in PLASMA OPTIMIZATION WITH FORMATIONAL AND FLUID INFORMATION,
- 2. United States Patent application on said invention, Application No. 17/008,176 , filed August 31, 2020 , entitled PLASMA OPTIMIZATION WITH FORMATIONAL AND FLUID INFORMATION, Halliburton Reference No. 2020-IPM-104032U1 US; (The undersigned hereby grant(s) the firm of C. Tumey Law Group, PLLC of 1150 Clear Lake City Blvd., Suite 201, Houston, Texas 77062 the power to insert on this assignment any further identification, including the application number and filing date, which may be necessary or desirable in order to comply with the rules of the United States Patent and Trademark Office for recordation of this document);
- 3. All applications for patent or like protection on said invention that have now been or may in the future be made by me or my legal representatives, including any continuation, continuation-in-part and any other utility applications that may be based on this invention, whether in the United States of America or in any other country or place anywhere in the world;
- 4. All patents and like protection that have now been or may in the future be granted on said invention to me or my legal representatives, whether in the United States of America or in any other country or place anywhere in the world;
- 5. All substitutions for and divisions, continuations, continuations-in-part, renewals, reissues, extensions, and the like of said applications and patents and like grants, including without limitation, those obtained or permissible under past, present and future laws and statutes;
- 6. All rights of action on account of past, present and future unauthorized use of said invention and for infringement of said patents and like protection;
- 7. The right in ASSIGNEE to file in its name applications for patents and like protection for said invention in any country or countries foreign to the United States; and
- 8. All international rights of priority associated with said invention, applications, patents and like protection and I covenant that I, and my heirs, legal representatives, assigns, administrators, and executors,

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will, at the expense of ASSIGNEE, its successors and assigns, execute all papers and perform such other acts as may be reasonably necessary to give ASSIGNEE, its successors and assigns, the full benefit of this Assignment.

Executed this 11th day of May , 2020

**RECORDED: 09/01/2020** 

**Mathew Dennis Rowe** 

PATENT REEL: 053660 FRAME: 0579